Search Notes			

lication	

Applicant(s)/Patent under Reexamination

09/670,462

Examiner

OGURA ET AL. Art Unit

Clemence Han

2665

SEARCHED			
Class	Subclass	Date	Examiner
370	224, 252	6/20/2005	сн
370	395.5	6/20/2005	СН
370	395.51	6/20/2005	СН
370	468	6/20/2005	СН
709	223, 224	6/20/2005	СН
709	225, 226	6/20/2005	СН
709	229	6/20/2005	СН

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
	<u> </u>		
.			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
east	6/20/2005	СН